## Notice of References Cited Application/Control No. 09/843,014 Examiner Huy Q Phan Applicant(s)/Patent Under Reexamination VAISANEN, RISTO Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,446,762 A	08-1995	Ohba et al.	375/324
	В	US-5,436,931 A	07-1995	Minami, Yoichiro	375/334
	С	US-6,198,317	03-2001	Chow et al.	327/116
	D	US-5,920,214	07-1999	Lee et al.	327/147
	ΕÚ	US-6,046,628	04-2000	Sasaki, Teruo	329/300
	F	US-			
	G.	US-			
	Н	US-			-
	l	US-	·		
	J	US-			
	K	US-			
. <u> </u>	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
:	N				i	
	0					
	Р					
	Q	•				
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	٧						
	W						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.